



Attorney Docket No.: F064

288/  
#5/IDB  
8/30/02  
LW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SERIAL NO.: 09/765,806

ART UNIT: 2881

APPLICANT: Gerlach, et al.

EXAMINER: Not Assigned

FILING DATE: January 19, 2001

TITLE: Shaped and Low Density Focused Ion Beams

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Pursuant to the guidelines for Information Disclosure Statements, 37 C.F.R. §§ 1.97-1.98, attached hereto is PTO Form 1449 (one sheet) with references listed for consideration by the Office.

In accordance with 37 C.F.R. § 1.98(a), copies of the listed written references are being provided.

In accordance with 37 C.F.R. §§ 1.97(g)-(h), the filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made or an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

This Information Disclosure Statement is being filed before the mailing of a first Office action on the merits.

Respectfully submitted,

Date: 1/21/02

By:

Michael O. Scheinberg  
Michael O. Scheinberg  
Patent Reg. 36,919  
P.O. Box 164140  
Austin, Texas 78716-4140  
Telephone: (512) 328-9510  
Facsimile: (512) 306-1963

RECEIVED  
JAN 21 2002  
PTO

CERTIFICATE OF MAILING

I hereby certify that this paper or fee is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the 21th day of January, 2002

By:

Kathleen Scheinberg  
Kathleen Scheinberg